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Sheet 1 of 1

Form 1449	Atty. Docket No.: 303.324US2	Serial No. 09/256,643
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	Applicant: Leonard Forbes et al.	
	Filing Date: February 23, 1999	Group: 2822

U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
MT	6,144,581	11/07/2000	Diorio, C.J., et al.	365	185.03	11/30/98
MT	6,163,066	12/19/2000	Forbes, L., et al.	257	632	08/24/98

FOREIGN PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
MS	01-115162	05/08/1989	Japan	H01L	29/78		X
	0291951	08/04/1993	European	H01L	29/64		
	04-056769	02/24/1992	Japan	C23C	16/32		X
	0681333	11/08/1995	European	H01L	29/788		
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	62-122275	06/03/1987	Japan	H01L	27/78		X
	63-181473	07/26/1988	Japan	H01L	29/78		X
	63-219172	09/12/1988	Japan	H01L	29/78		X
MT	63-289960	11/28/1988	Japan	H01L	29/64		X

OTHER DOCUMENTS

**Examiner Initial	(Including Author, Title, Date, Pertinent Pages, Etc.)
MS.	Zirinsky, S., et al., "Electrical Resistivity of Amorphous Silicon Resistor Films", <u>Extended Abstracts of the Spring Meeting of the Electrochemical Society</u> , Washington, DC, pp. 147-149, (1971)

Examiner <u>Michael Trinh</u>	Date Considered <u>7/11/01</u>
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*Substitute Disclosure Statement Form (PTO-1449)

**EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.